

Sub A1

What is claimed is:

- 1 1. An electrode for a plasma arc torch, the electrode comprising:  
2 an elongated electrode body formed of a high thermal conductivity material and having a  
3 bore disposed in a bottom end of the electrode body; and  
4 a ring-shaped insert comprising a high thermionic emissivity material disposed in the  
5 bore.

- 1 2. The electrode of claim 1 wherein the bore is ring-shaped.

- 1 3. The electrode of claim 1 wherein the high thermionic emissivity material is hafnium or  
zirconium.

4. 3 The electrode of claim 1 wherein the insert further comprises a closed end which defines  
an exposed emission surface.

5. 4 The electrode of claim 1 wherein the insert comprises a first ring-shaped member formed  
of a high thermionic emissivity material and a second cylindrical member formed of a high  
thermal conductivity material disposed in the first ring-shaped member.

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6. The electrode of claim 1 wherein the insert comprises a first ring-shaped member  
2 comprising of a high thermionic emissivity material disposed in a second ring-shaped member  
3 formed of a high thermal conductivity material.

- 1 7. 6 The electrode of claim 1 or 6 wherein the second insert comprises copper, silver, gold, or  
2 platinum.

1 8<sup>7</sup> The electrode of claim ~~10~~<sup>1</sup> wherein the insert comprises a rolled pair of adjacent layers,  
2 the first layer comprising the high thermal conductivity material and a second layer comprising  
3 the high thermionic emissivity material.

1 9<sup>8</sup> The electrode of claim 1 wherein the insert further comprises a high thermal conductivity  
2 material.

Sub A<sup>3</sup> } 10. An electrode for a plasma arc torch, the electrode comprising:  
2 an elongated electrode body formed of a high thermal conductivity material and having a  
3 bore disposed in a bottom end of the electrode body; and  
4 an insert disposed in the bore and comprising a high thermal conductivity material and a  
5 high thermionic emissivity material.

6 11. The electrode of claim ~~10~~ wherein the high thermionic emissivity material is hafnium or  
7 zirconium.

8 12<sup>10</sup> The electrode of claim ~~10~~<sup>9</sup> wherein the a high thermal conductivity material comprises  
9 copper, silver, gold, or platinum.

10 13<sup>11</sup> The electrode of claim ~~10~~<sup>9</sup> wherein the insert comprises a rolled pair of adjacent layers,  
11 the first layer comprising the high thermal conductivity material and a second layer comprising  
12 the high thermionic emissivity material.

13 14<sup>12</sup> The electrode of claim ~~13~~<sup>11</sup> wherein the first layer comprises hafnium plating and the  
14 second layer comprises a copper foil.

15 15<sup>13</sup> The electrode of claim ~~10~~<sup>9</sup> wherein the electrode body has a ring-shaped bore and the  
16 insert is ring-shaped.

1 16. <sup>14</sup> The electrode of claim 15 <sup>13</sup> wherein the insert further comprises a closed end which defines  
2 an exposed emission surface.

1 17. <sup>17</sup> The electrode of claim 10 <sup>9</sup> wherein the insert comprises:  
2 a cylindrical high thermal conductivity material having a plurality of parallel bores  
3 disposed in a spaced arrangement; and  
4 a plurality of elements comprising the high thermionic emissivity material, each member  
5 being disposed in one of the plurality of bores.

Sub A4 18. A method of manufacturing an electrode for a plasma arc torch comprising:  
2 a) providing an elongated electrode body formed of a high thermal conductivity material;  
3 b) forming a bore at a bottom end of the elongated electrode body relative to a central  
4 axis through the electrode body; and  
5 c) inserting a ring-shaped insert comprising a high thermionic emissivity material in the  
6 bore.

19. <sup>17</sup> The method of claim 18 <sup>14</sup> wherein step b) comprises:  
2 b1) forming a ring-shaped bore.

1 20. <sup>18</sup> The method of claim 19 <sup>17</sup> wherein step c) comprises:  
2 c1) inserting in the bore an insert having one closed end which defines an exposed  
3 emission surface.

1 21. <sup>19</sup> The method of claim 18 <sup>14</sup> wherein step b) comprises:  
2 b1) forming a cylindrical bore.

1 ~~22.~~<sup>20</sup> The method of claim ~~21~~<sup>19</sup> wherein step b) comprises:

2 b1) forming the insert from a first ring-shaped member comprising a high thermionic  
3 emissivity material and a second cylindrical member comprising a high thermal conductivity  
4 material disposed in the ring-shaped first insert.

1 ~~23.~~<sup>21</sup> The method of claim ~~22~~<sup>20</sup> wherein step b) comprises:

2 b1) forming a cylindrical bore having an inner bore and a deeper outer bore, such that the  
3 first member fits in the outer bore and the second member fits in the inner bore.

1 ~~24.~~<sup>22</sup> The method of claim ~~22~~<sup>20</sup> wherein step b) comprises:

2 b1) forming a cylindrical bore having an outer bore and a deeper inner bore, such that the  
3 first member fits in the outer bore and the second member fits in the inner bore.

1 ~~25.~~<sup>23</sup> The method of claim ~~18~~<sup>14</sup> wherein step c) further comprises:

2 c1) forming the insert from a composite powder mixture of a high thermal conductivity  
3 material and a high thermionic emissivity material.

1 ~~26.~~<sup>24</sup> The method of claim ~~25~~<sup>23</sup> wherein the composite powder mixture comprises grains of the  
2 thermal conductivity material coated with the high thermal conductivity material.

1 ~~27.~~<sup>25</sup> The method of claim ~~18~~<sup>14</sup> wherein step c) further comprises forming the insert by:

2 c1) forming a plurality of parallel bores disposed in a spaced arrangement within a  
3 cylindrical high thermal conductivity material; and

4 c2) positioning each of a plurality of elements comprising the high thermionic emissivity  
5 material in a respective one of the plurality of bores.

1 28. <sup>26</sup> The method of claim 18 <sup>18</sup> wherein step c) further comprises forming the insert by:  
2 c1) placing a first layer comprising the high thermal conductivity material adjacent a  
3 second layer comprising the high thermionic emissivity material; and  
4 c2) rolling the adjacent layers.

Sub A 5 29. A method of manufacturing an electrode for a plasma arc cutting torch, comprising:  
6 a) providing an elongated electrode body formed of a high thermal conductivity material;  
7 b) forming a bore at a bottom end of the elongated electrode body relative to a central  
8 axis extending longitudinally through the electrode body;  
9 c) forming an insert comprising a high thermal conductivity material and a high  
10 thermionic emissivity material; and  
11 d) inserting in the bore of the electrode body.

30. <sup>24</sup> The method of claim 29 <sup>27</sup> wherein step c) comprises:  
c1) providing a first layer of high thermal conductivity material and disposed adjacent a  
second layer of high thermionic emissivity material; and

4 c2) rolling the adjacent layers.

1 31. <sup>29</sup> The method of claim 29 <sup>27</sup> wherein step c) comprises the steps of:

2 c1) forming a composite powder comprising the high thermal conductivity material and  
3 the high thermionic emissivity material; and

4 c2) sintering the powder to form the insert.

1 32<sup>30'</sup> The method of claim 31<sup>29</sup> wherein step c1) comprises:

2 c11) coating grains of high thermionic emissivity material with the high thermal  
3 conductivity material.

4 33<sup>31'</sup> The method of claim 28<sup>28</sup> wherein step c) comprises:

5 c1) forming a plurality of parallel bores disposed in a spaced arrangement within the high  
6 thermal conductivity material; and

7 c2) positioning each of a plurality of elements comprising the high thermionic emissivity  
8 material in a respective one of the plurality of bores.

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